



Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109716		APPLICATION NO. 09/857,569	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Masatake NAKANO et al.			
				FILING DATE June 7, 2001		1763	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
GAG	1	5,494,849	02/27/1996	Iyer et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
GAG	2	JP A 11-026336 (abstract only)	01/29/1999	Japan			
GAG	3	EP 0 451 993 A2	10/16/1991	Europe			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
GAG	4	M. Bruel et al., "Smart-Cut: A New Silicon On Insulator Material Technology Based on Hydrogen Implantation and Wafer Bonding", Jpn. J. Appl. Phys., Vol 36, 1997, pp 1636-1641					
EXAMINER <i>George Goudreau</i>				DATE CONSIDERED 2-041			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: July 15, 2003